

# Program at a Glance

## DAY 1 / September 17<sup>Sun.</sup>, 2023

Time	
16:00~17:00	<b>Registration</b> (Room 402, 4F)
17:00~19:00	<b>Welcome Reception</b> (Room 402, 4F)
19:00~	<b>ICMI Member Meeting</b> (Conference Room E4)

## DAY 2 / September 18<sup>Mon.</sup>, 2023

Time	Room E1 Session A	Room E2 Session B	Room E3 Session C	Room E4 Session D	Room E5 Session E, F	Lobby
08:30~09:00	<b>Opening Ceremony</b> (Room E5)					Registration (08:00~18:00)
09:00~10:30	<b>Keynote Session-1 (Keynote 1, 2&amp;3)</b> (Room E5)					
10:30~10:45	Coffee Break					
10:45~12:10	<b>A-1</b> In-Process Measurement - I	<b>B-1</b> Dimensional Metrology - I	<b>C-1</b> Optical Interferometry - I	<b>D-1</b> Laser Material Processing - I	<b>E-1</b> Precision Metrology - I	
12:10~13:50	Lunch					
13:50~15:15	<b>A-2</b> In-Process Measurement - II	<b>B-2</b> Frequency Comb - I	<b>C-2</b> Optical Interferometry - II	<b>D-2</b> Laser Material Processing - II	<b>E-2</b> Precision Metrology - II	
15:15~16:25	Post Only Session & Coffee Break					
16:25~18:00	<b>A-3</b> Intelligent Measurement - I	<b>B-3</b> Frequency Comb - II	<b>C-3</b> Metrology & Inspection - I	<b>D-3</b> Material Characterization	<b>F-1</b> Machine Learning & Signal Processing I	

## DAY 3 / September 19<sup>Tue.</sup>, 2023

Time	Room E1 Session A	Room E2 Session B	Room E3 Session C	Room E4 Session D, E	Room E5 Session F	Lobby
08:30~10:30	<b>Keynote Session-2 (Keynote 4, 5, 6&amp;7)</b> (Room E5)					Registration (08:00~17:00)
10:30~10:45	Coffee Break					
10:45~12:10	<b>A-4</b> Intelligent Measurement - II	<b>B-4</b> Dimensional Metrology - II	<b>C-4</b> Microscopy & Profilometry - I	<b>D-4</b> Sensors & Actuators	<b>F-2</b> Machine Learning & Signal Processing II	
12:10~14:00	Lunch					
14:00~15:25	<b>A-5</b> Intelligent Measurement - III	<b>B-5</b> Frequency Comb - III	<b>C-5</b> Metrology & Inspection - II	<b>E-3</b> Precision Metrology - III	<b>F-3</b> Machine Learning & Signal Processing III	
15:25~15:40	Coffee Break					
15:40~17:15	<b>A-6</b> Intelligent Measurement - IV	<b>B-6</b> Uncertainty, Traceability & Calibration	<b>C-6</b> Microscopy & Profilometry - II	<b>E-4</b> Precision Metrology - IV	<b>F-4</b> Machine Learning & Signal Processing IV	
17:45~20:30	<b>Banquet</b> (Cheonggyesan Yettgol Fortress Restaurant)					

## DAY 4 / September 20<sup>Wed.</sup>, 2023

Time	
08:30~13:00	<b>Technical Tour</b> (Korea Institute of Industrial Technology)
09:00~13:00	<b>Culture Tour</b> (Gyeongbokgung Palace)